INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 11, 2026	
IGI Report Number	LG833698494
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.08 - 9.21 X 5.79 MM

GRADING RESULTS

Carat Weight	3.00 CARATS
Color Grade	E
Clarity Grade	SI 1
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

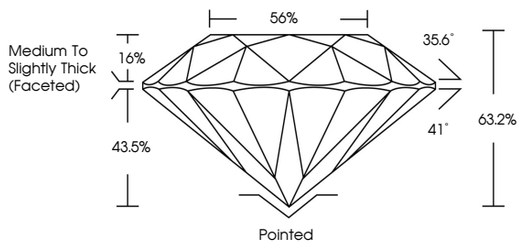
Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG833698494

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG833698494

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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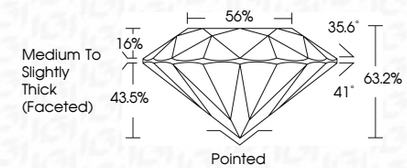

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ROUND BRILLIANT
9.08 - 9.21 X 5.79 MM

Carat Weight	3.00 CARATS
Color Grade	E
Clarity Grade	SI 1
Cut Grade	EXCELLENT
Depth	63.2%
Table	56%
Girdle	Medium To Slightly Thick (Faceted)
Culet	Pointed
Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
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